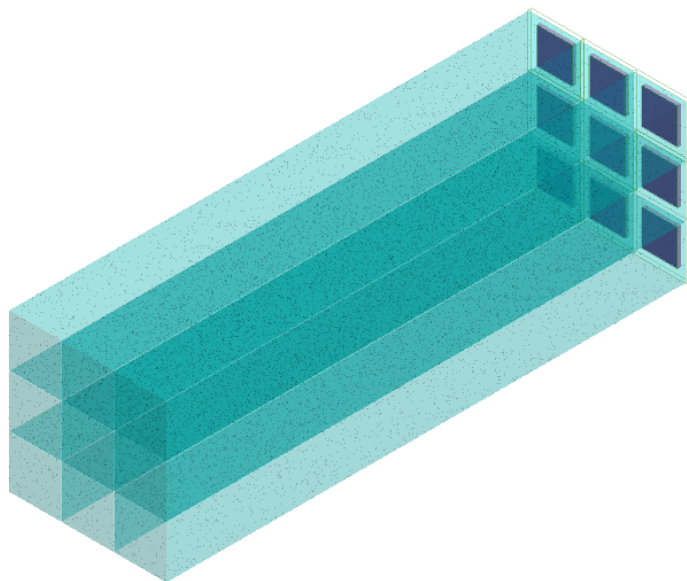


Optical simulation studies of S14160-6010PS MPPC



Artur Hoghmrtsyan



Used Code from:

<https://github.com/JeffersonLab/glass-prototype>

Author: Petr Stepanov

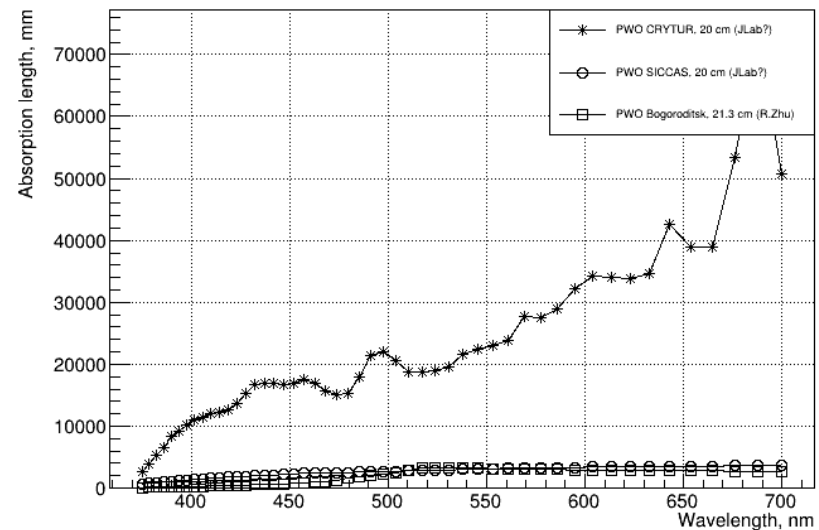
Provided by: Dmitry Kalinkin

Simulation Setup

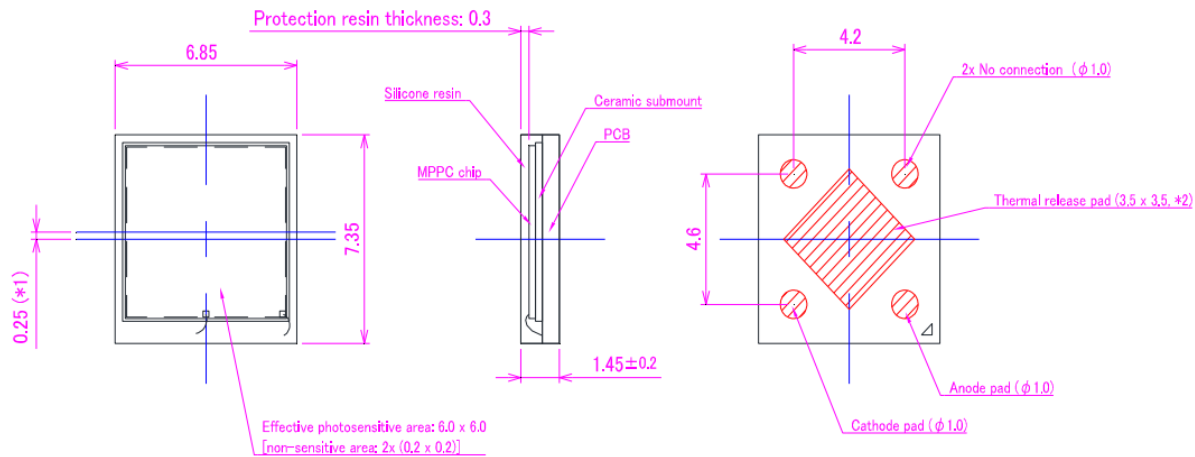
- Material - PWO-CRYTUR
- Matrix - 1x1,5x5
- Wrap material - VM2000
- Physics List - FTFP_BERT

- 1Mev - 300 Op. Photons
- Number of events - 1000
- Particle - e-
- Finish model - dielectric-metal
- Finish type - unified

Calculated PWO Absorption Length



S14160-6010PS/6015PS properties



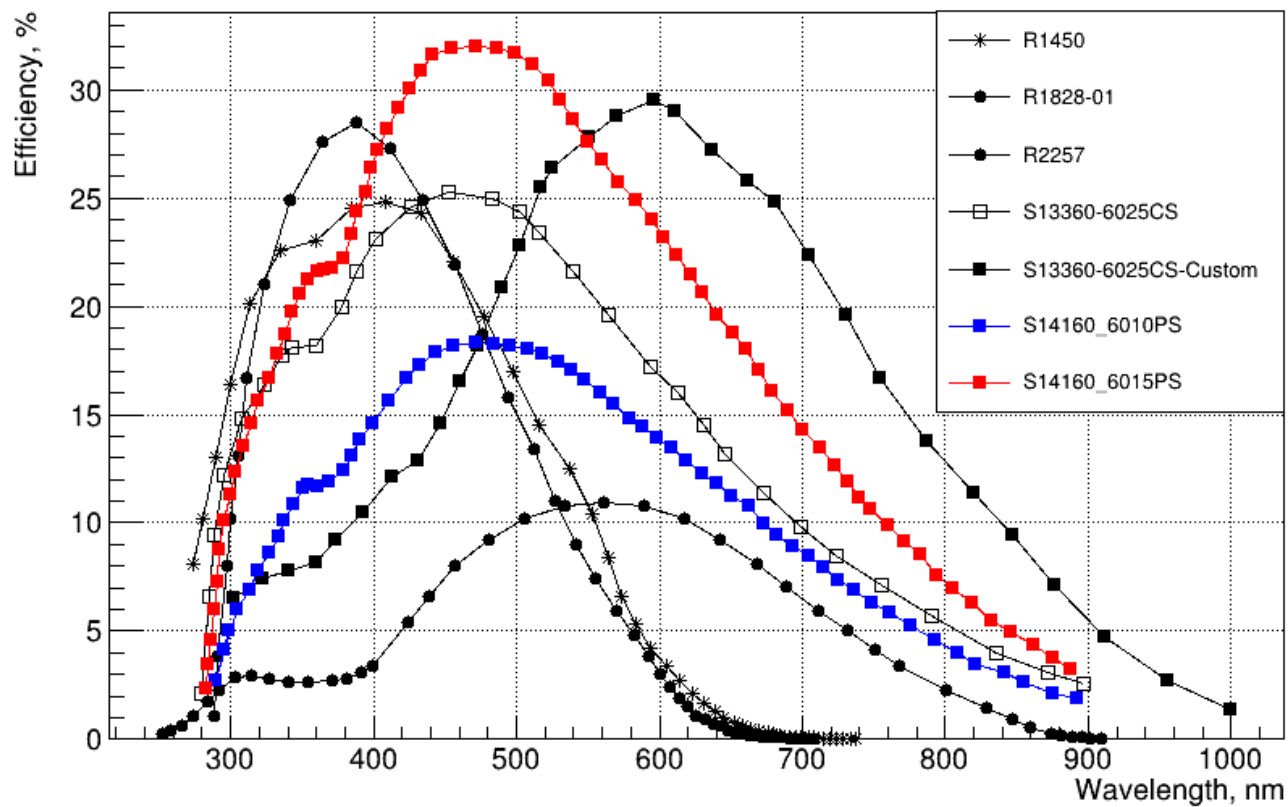
*1 : Chip center to PKG center

*2 : The thermal pad is not electrically but thermally connected to MPPC chip.
It is recommended that the pad is connected to ground plane for thermal release.

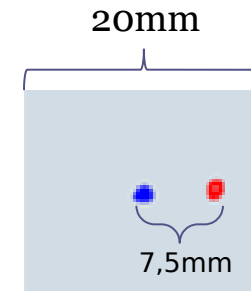
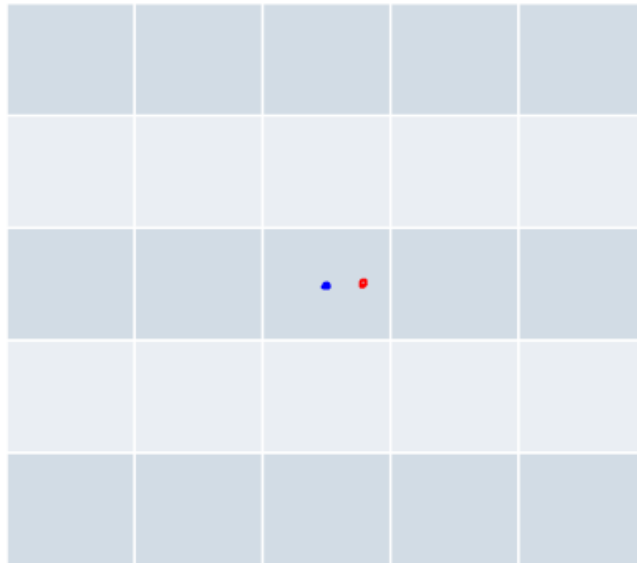
General tolerance : ±0.1

Instead of 4 siPM's with size 6.85mm*7.35mm on one crystal. One siPM with size were used.

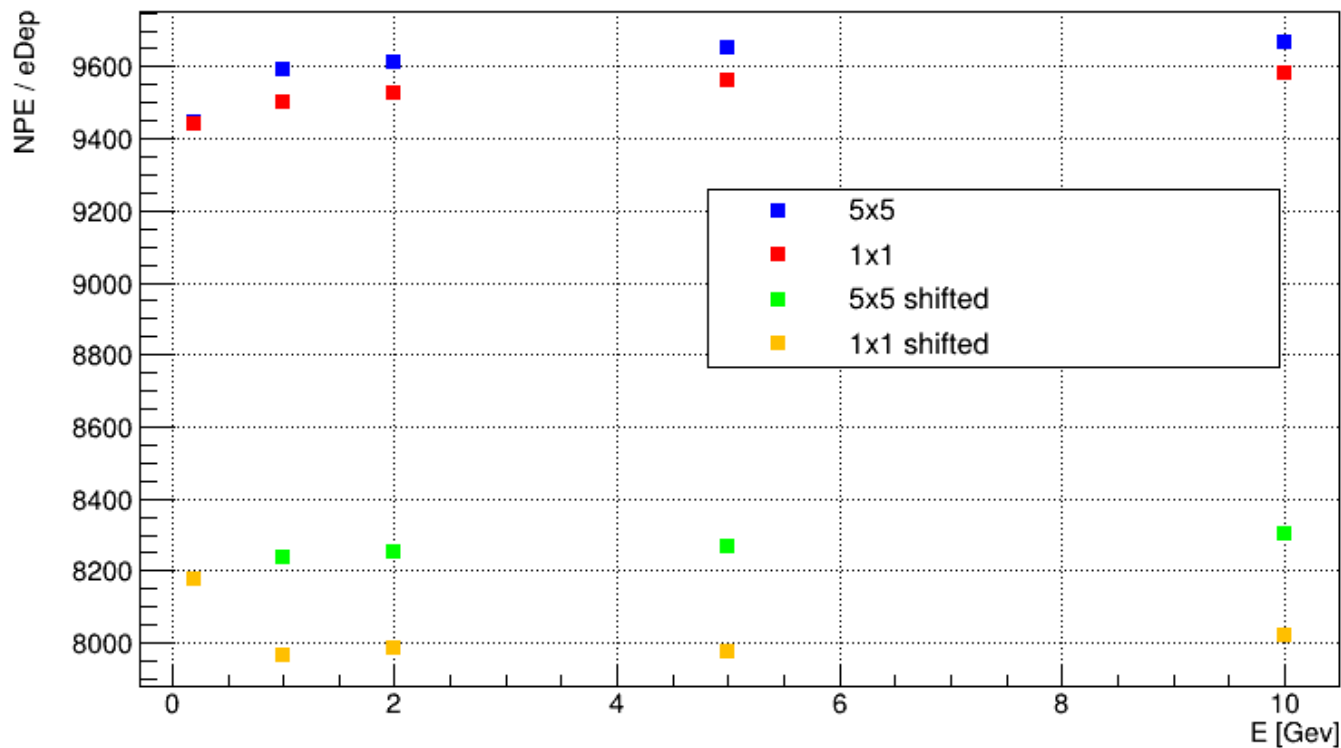
Detector Quantum efficiencies



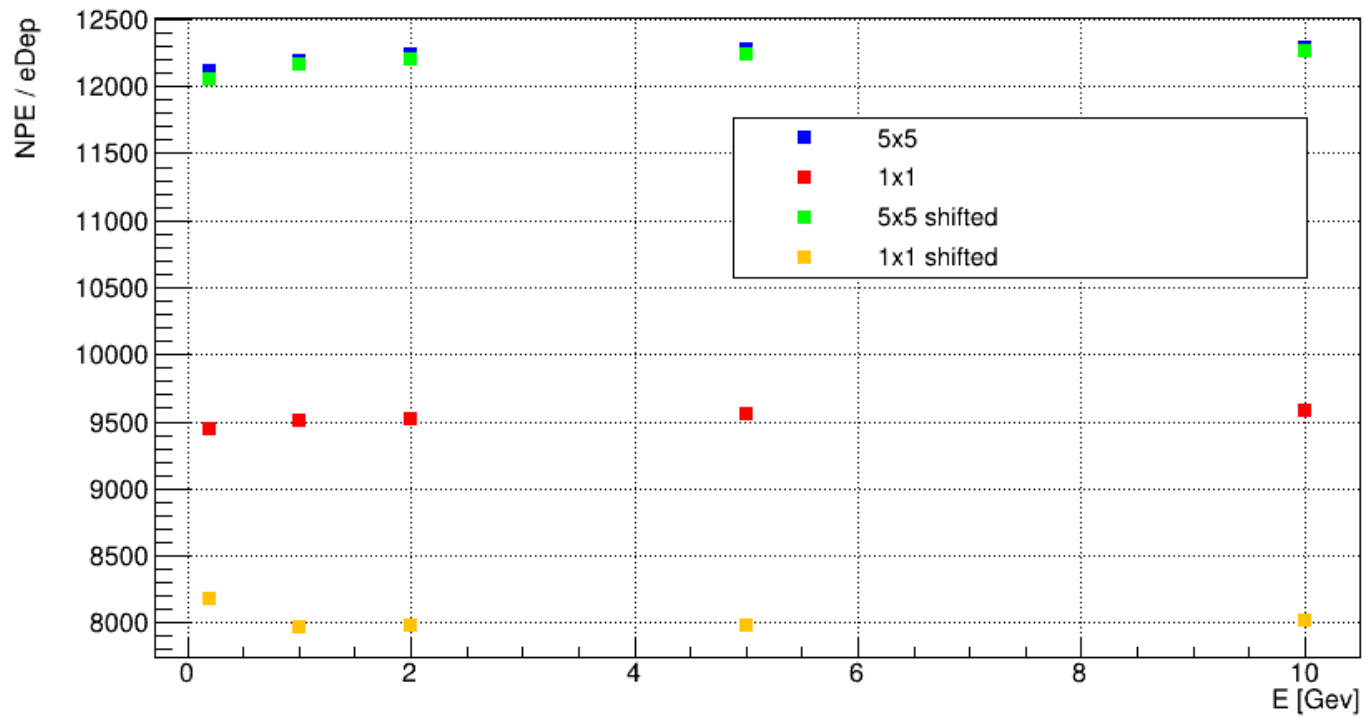
Number of photons that reach the sensors were calculated for 5x5 and 1x1 crystal configurations, by throwing to the center of central crystal and by shifting 7,5mm to the side



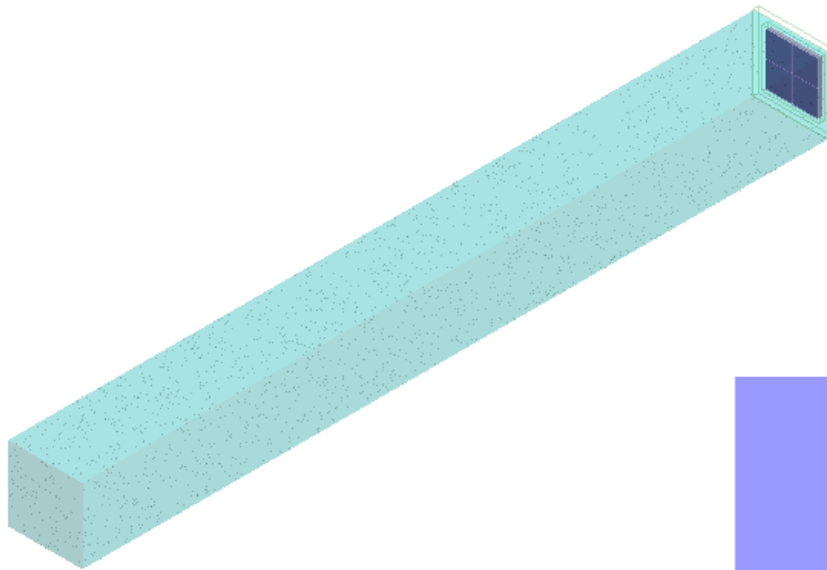
Number of photons that reach the sensors per unit of energy deposited as a function of incident electron momentum, **per Event**



Number of photons that reach the sensors per unit of energy deposited as a function of incident electron momentum, in *All Crystals*



Simulations for 4 SiPMs in one crystal



What the thickness of
Mu Metal should be?

What size to use between
SiPMs?

PWO Crystal



SiPM area

Mu Metal